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INFORMATION DISCLOSURE	First Named Inventor	Onishi		
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(Use as many sheets as necessary)	Examiner Name			
Sheet 1 of 2	Attorney Docket Number	SO-1		

			U. S. PATEN	DOCUMENTS	
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ^{2 (f Innum)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevan Figures Appear
RM	1	^{US-} 4,515,675	05/07/1985	Kieser et al	<u> </u>
	2	^{US-} 5,482,611	01/09/1996	Helmer et al	
	3	^{US-} 5,512,150	04/30/1996	Bourez et al	
	4	^{US-} 5,597,459	01/28/1997	Altshuler	
. .	5	^{US-} 5,685,959	11/11/1997	Bourez et al	
	6	^{US-} 5,865,961	02/02/1999	Yokoyama et al	
V	7	us- 6,159,351	12/12/2000	J'Afer et al	
RM	8	US- 6,251,242 B1	06/26/2001	Fu et al	
		US-			
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FOREIGN PATENT DOCUMENTS						
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Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
RM	1	Ohnishi et al, Chemical Vapor Deposition of Single-Crystalline ZnO Film with Smooth Surface on Intermediately Sputtered ZnO Thin Film on Sapphire,	
		Japanese Jorn. of App. Physics, vol. 17, no. 5, May 1978, pp. 773-778	
RM	2	Onishi et al, Transparent and Highly Oriented ZnO films Grown at Low Temperature by Sputtering with a Modified Sputter Gun,	
		Applied Phys. Letters, vol. 38 no. 6 March 1981	
			-

Examiner	/Rodney Mcdonald/	Date	01/24/2007
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